

Form PTO-1449 U.S. Department of Commerce (REV. 2-82) Patent and Trademark Office INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)	Atty. Docket No. A35043-PCT-USA (072944.0155)	U.S. Application No. 10/070,477 International Appln. No. PCT/KR00/00956
	Applicants Kim et al.	
	International Filing Date August 25, 2000	Group To be assigned 1752
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	Document No.									Date	Country	Class	Subclass	Translation	
														Yes	No
NEW		0	5	2	4	9	6	8	3	9/28/1993	JP				
		0	5	2	3	2	7	0	6	9/10/1993	JP				
		0	5	1	1	3	6	6	7	5/7/1993	JP				
NEW				2	2	7	6	6	0	1990	JP				

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

NEW		MacDonald et al., "Airborne Chemical Contamination of a Chemically Amplified Resist," SPIE, Vol. 1466 (1991).
		Schlegel, 37th Japanese Applied Physics Society Announcement, 28p-ZE-4 (1990).
		Ueno et al., 36th Japanese Applied Physics Society Announcement, 1p-k-7, (1989).
NEW		Ito et al., "Applications of Photoinitiators to the Design of Resists for Semiconductor Manufacturing," <i>Polymers in Electronics</i> , American Chemical Society, pp. 11-23 (1984).

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Date Considered

2/14/2004

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U.S. PATENT DOCUMENTS

*Exam. Init.	Document No.	Date	Name	Class	Subclass	Filing Date if Appro.
kw	5 7 7 3 1 9 1	6/30/1998	Padmanaban et al.			
	5 6 7 9 4 9 5	10/21/1997	Yamachika et al.			
	5 5 5 6 7 3 4	9/17/1996	Yamachika et al.			
	5 4 9 2 7 9 3	2/20/1996	Breyta et al.			
	5 4 4 3 6 9 0	8/22/1995	Takechi et al.			
	5 3 1 0 6 1 9	5/10/1994	Crivello et al.			
kw	4 4 9 1 6 2 8	1/1/1985	Ito et al.			

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Document No.	Date	Country	Class	Subclass	Translation Yes No
kw 0 8 7 7 2 9 4 A 1	11/11/1998	EP			
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0 7 8 6 7 0 1 A 1	7/30/1997	EP			
kw 0 4 0 4 2 0 6 A 2	5/2/1983	EP			

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